

Substitute Form PTO-1449 (Modified) Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 06618-424001	Application No. 09/532,461
	Applicant Marc A. Nicolet et al.		
	Filing Date March 22, 2000	Group Art Unit 1775	

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
	AC						
	AD						
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Foreign Patent Documents or Published Foreign Patent Applications								
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							Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
<i>PN</i>	AQ	Pisch et al., "Thermodynamic calculations offer insight in the stability of materials; the annealing behavior of amorphous Ru-Si-O and Ir-Si-O thin films", <u>Calphad</u> , Vol. 25, No. 4, pp. 639-644 (2001)
	AR	
	AS	
	AT	

Examiner Signature <i>M. Nicolet</i>	Date Considered 6/29/05
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